

Electronic Acknowledgement Receipt

EFS ID:	4985110
Application Number:	10593857
International Application Number:	
Confirmation Number:	5813
Title of Invention:	PLASMA CHAMBER HAVING PLASMA SOURCE COIL AND METHOD FOR ETCHING THE WAFER USING THE SAME
First Named Inventor/Applicant Name:	Nam Hun Kim
Customer Number:	23363
Filer:	D. Bruce Prout/Marti Carrillo
Filer Authorized By:	D. Bruce Prout
Attorney Docket Number:	58409/N305
Receipt Date:	17-MAR-2009
Filing Date:	22-SEP-2006
Time Stamp:	18:23:53
Application Type:	U.S. National Stage under 35 USC 371

Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$1085
RAM confirmation Number	13352
Deposit Account	031728
Authorized User	

The Director of the USPTO is hereby authorized to charge indicated fees and credit any overpayment as follows:

Charge any Additional Fees required under 37 C.F.R. Section 1.20 (Post Issuance fees)

Charge any Additional Fees required under 37 C.F.R. Section 1.21 (Miscellaneous fees and charges)

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/Message Digest	Multi Part/.zip	Pages (if appl.)
1	Issue Fee Payment (PTO-85B)	N305-58409_PTOL-85.pdf	92448 30c982423e04b9663ef445c298f1e7a70c49f 8d89	no	1

Warnings:**Information:**

2	Post Allowance Communication - Incoming	N305-58409_RFA.pdf	43309 80342fc1ca0e077cd4440b7d5b41c08e0f53 6753e	no	2
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Warnings:**Information:**

3	Fee Worksheet (PTO-06)	fee-info.pdf	33765 75642ed45b33eb513535046c7-5a135469 28d35	no	2
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Warnings:**Information:****Total Files Size (in bytes):**

169522

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.